

Application/Control No.	Applicant(s)/Patent under Reexamination
09/420,208	HERMAN ET AL.
Examiner	Art Unit
Chau Nguyen	2176

SEARCHED			
Class	Subclass	Date	Examiner
709	227	6/12/2002	CN
709	245	6/12/2002	CN
709	231	6/12/2002	CN
709	228	6/12/2002	CN
709	203	6/12/2002	CN
709	221	6/12/2002	CN
709	217	6/12/2002	CN
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INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
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SEARCH NO (INCLUDING SEARCH		)
	DATE	EXMR
East Reports	6/6/2002	СИ
	6/7/2002	СИ
	6/10/2002	CN
	06/12/2002	CN
	6/13/2002	CN
	6/14/2002	CN
Updated Search on East Reports	12/23/2002	CN
	12/26/2002	CN

Search Notes (continued)



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INTERFERENCE SEARCHED			
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SEARCH NO		)
	DATE	EXMR
Updated Search on East Reports	06/27/2003	CN
Updated Search on East Reports	12/22/2003	CN
Updated Search on East Reports	06/26/2004	CN
Updated Search on East Reports	02/15/2005	CN
Updated Search on East Reports	8/2/2005	CN
	8/3/2005	CN
Updated Search on East Report	12/29/2005	CN
NPL Search on IEEE Database	12/29/2005	CN